



IFW 1732

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No. : 10/099,915  
For : Method for Annealing an Electrodeposition Structure  
Applicant : Grimmer et al.  
Filed : March 15, 2002  
Art Unit : 1732  
Examiner : Leo B Tentoni  
  
Docket : TRM TR010001  
Customer No. : 32047

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on June 2, 2004, at Manchester, New Hampshire.

By

Carol McClelland

**AMENDMENT A**

Sir:

This Amendment is in response to the Office Action mailed May 17, 2004. As this response is being filed within the two-month shortened statutory period of reply no extension of time is believed necessary. However, Applicant conditionally petitions for an extension of time to provide for the possibility that the need for an extension has inadvertently been overlooked. Please charge Deposit Account No. 50-2121 for any necessary extension fees. Please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin of page 4 of this paper.